



2879

In re Application of:

TAMAKI KOBAYASHI ET AL.

Application No.: 09/440,535

Filed: November 16, 1999

For: SUBSTRATE FOR ELECTRON SOURCE,
ELECTRON SOURCE AND IMAGE FORMING
APPARATUS, AND MANUFACTURING METHOD
THEREOF

THE COMMISSIONER FOR PATENTS
Washington, D.C. 20231

Sir:

Transmitted herewith is an amendment in the above-identified application.

No additional fee is required.

The fee has been calculated as shown below

CLAIMS AS AMENDED						
	(2) CLAIMS REMAINING AFTER AMENDMENT		(4) HIGHEST NO. PREVIOUSLY PAID FOR	(5) PRESENT EXTRA	RATE	ADDITIONAL FEE
TOTAL CLAIMS	* 113	MINUS	** 138	0	x \$9 \$18	0
INDEP. CLAIMS	* 2	MINUS	*** 3	0	x \$42 \$84	0
Fee for Multiple Dependent claims \$140°/\$280						0
TOTAL ADDITIONAL FEE FOR THIS AMENDMENT---						0

* If the entry in Column 2 is less than the entry in Column 4, write "0" in Column 5.

** If the "Highest Number Previously Paid For" IN THIS SPACE is less than 20, write "20" in this space.

*** If the "Highest Number Previously Paid For" IN THIS SPACE is less than 3, write "3" in this space.

°Verified Statement claiming small entity status is enclosed, if not filed previously.

TO 2879 MAIL ROOM
MAY 23 2002
RECEIVED

A check in the amount of \$_____ is enclosed.

Charge \$_____ to Deposit Account No. 06-1205. A duplicate copy of this sheet is enclosed.

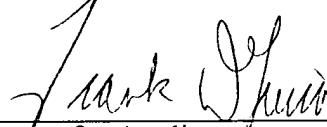
Any prior general authorization to charge an issue fee under 37 C.F.R. 1.18 to Deposit Account No. 06-1205 is hereby revoked. The Commissioner is hereby authorized to charge any additional fees under 37 C.F.R. 1.16 and 1.17 which may be required during the entire pendency of this application, or to credit any overpayment, to Deposit Account No. 06-1205. A duplicate copy of this paper is enclosed.

A check in the amount of \$_____ to cover the fee for a _____ month extension is enclosed.

A check in the amount of \$_____ to cover the Information Disclosure Statement fee is enclosed.

Applicants' undersigned attorney may be reached in our New York office by telephone at (212) 218-2100. All correspondence should continue to be directed to our address given below.

Respectfully submitted,



Attorney for Applicants
Registration No. 42,476

FITZPATRICK, CELLA, HARPER & SCINTO
30 Rockefeller Plaza
New York, New York 10112-3801
Facsimile: (212) 218-2200

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PATENT APPLICATION

Amend
129
5/25/02
A. Patel
Group Art Unit: 2879
SEARCHED INDEXED
MAILED 5/25/02
FEE PAID
MAY 14 2002
U.S. PATENT AND TRADEMARK OFFICE

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

TAMAKI KOBAYASHI ET AL.

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For: SUBSTRATE FOR ELECTRON
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AND IMAGE FORMING APPARA-
TUS, AND MANUFACTURING
METHOD THEREOF

Examiner: A. Patel

Group Art Unit: 2879

May 14, 2002

Commissioner For Patents
Washington, D.C. 20231

AMENDMENT

Sir:

In response to the Office Action of February 14, 2002, please amend the
above-identified application as follows:

*- Non-elected species claims
- Non-elected group claims
- Non- elected
- Non- elected
- Non- elected
- Non- elected*

I hereby certify that this correspondence is being deposited with the
United States Postal Service as first-class mail in an envelope
addressed to: Commissioner for Patents, Washington, D.C. 20231
on May 14, 2002.

(Date of Deposit)

FRANK A. DeLUCIA

(Name of Attorney for Applicant)

Frank A. DeLucia

May 14, 2002

Signature

Date of Signature